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## **BIB DATA SHEET**

## **CONFIRMATION NO. 4566**

SERIAL NUM	BER	FILING O	371(c)	CLASS			GROUP ART UNIT			ATTORNEY DOCKET NO.	
10/567,94	.3	02/10/2			438		4116		1217060312		
		RUL	E								
APPLICANTS Satoru Wakamatsu, Yamaguchi, JAPAN; Shigeki Sugimura, Yamaguchi, JAPAN; Yasuo Nakamura, Yamaguchi, JAPAN; Kenichi Tsujio, Yamaguchi, JAPAN;											
** <b>CONTINUING DATA</b> ********************************* This application is a 371 of PCT/JP04/11542 08/11/2004											
** <b>FOREIGN APPLICATIONS</b> ************************************											
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/29/2006											
Foreign Priority claime	eign Priority claimed Yes No STATE OR USC 119(a-d) conditions met Yes No Met after Allowance COUNTRY						IEETS WINGS	TOTAL S CLAIMS		INDEPENDENT CLAIMS	
M	fied and /BRITTANY M MARTINEZ/ JAPAN						21	6		2	
ADDRESS											
THE WEBB LAW FIRM, P.C. 700 KOPPERS BUILDING 436 SEVENTH AVENUE PITTSBURGH, PA 15219 UNITED STATES											
TITLE											
Tubular reaction vessel and process for producing silicon therewith											
							☐ All Fees				
	FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT						☐ 1.16 Fees (Filing)				
1 FII IIW3 FFF I						☐ 1.17 Fees (Processing Ext. of time)					
	No for following:						☐ 1.18 Fees (Issue)				
							☐ Other				
							☐ Credit				